



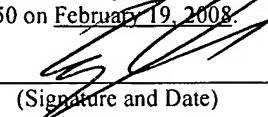
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT : Jae-Geol Cho et al. DOCKET NO.: 5000-1-501
SERIAL NO. : 10/735,192 EXAMINER : John A. McPherson
FILED : December 12, 2003 ART UNIT : 1795
FOR: METHOD OF FABRICATING MICRO-LENS AND METHOD OF
FABRICATING OPTICAL MODULE USING THE METHOD

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Mail Stop RCE, Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 19, 2008.

Steve Cha, Reg. No. 44,069
(Name of Registered Rep.)


(Signature and Date)

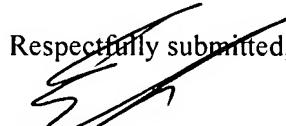
WITHDRAWAL FROM ISSUE

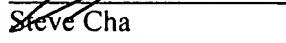
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Alexandria, VA 22313-1450

Dear Sir:

Applicants request withdrawal of the above-identified Patent Application from Issuance, to permit consideration of an Information Disclosure Statement Under §1.97 containing a reference cited in a Japanese Search Report dated December 11, 2007. The Issue Fee for this case is due February 19, 2008.

Favorable action on this Request for Extension of Time is courteously solicited.


Respectfully submitted,


Steve Cha
Attorney for Applicants
Registration No. 44,069

Cha & Reiter
210 Route 4 East, Suite #103
Paramus, NJ 07652
(201) 226-9245

Date: February 19, 2008